

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	1014259
<b>Application Number:</b>	09525477
<b>Confirmation Number:</b>	9792
<b>Title of Invention:</b>	INK-JET RECORDING DEVICE AND INK SUPPLY UNIT SUITABLE FOR IT
<b>First Named Inventor:</b>	Hisashi Miyazawa
<b>Correspondence Address:</b>	Lawrence Rosenthal Strock & Strock & Lavan LLP 180 Maiden Lane - New York NY 10038 US 212-806-6006 -
<b>Filer:</b>	David Lewis Schaeffer
<b>Filer Authorized By:</b>	
<b>Attorney Docket Number:</b>	Q58280
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<b>Application Type:</b>	Utility
<b>International Application Number:</b>	

### Payment information:

Submitted with Payment	no
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**File Listing:**

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Miscellaneous Incoming Letter	Request.pdf	226591	no	8

**Warnings:****Information:**

<b>Total Files Size (in bytes):</b>	226591
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**New Applications Under 35 U.S.C. 111**

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

**National Stage of an International Application under 35 U.S.C. 371**

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.